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TECHNOLOGY CENTER R3700

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: **Hyoung June KIM** ) Examiner; Quang T. Van  
Serial No.: **09/886,940** ) Art Unit: 3742  
Filed: **June 21, 2001** ) Our Ref: B-4227 618899-5/MSG/RP  
For: **METHODS & APPARATUSES FOR** ) Date: December 15, 2003  
**HEAT TREATMENT OF** ) Re: *Amendment and Response*  
**SEMICONDUCTOR FILMS UPON**  
**THERMALLY SUSCEPTIBLE NON-**  
**CONDUCTING SUBSTRATES**

**AMENDMENT AND RESPONSE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the non-final Office Action mailed on August 15, 2003, a response to which is due no later than **February 15, 2004**, Applicant submits this paper together with a petition for a one month extension of time pursuant to 37 C.F.R. 1.136(a) and a check in the amount of \$110.00 for the fee set forth in 37 C.F.R.1.17(a)(1). Please amend the above-identified application as described below and consider the following remarks. **All amendments and remarks herein are made without prejudice.**

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Abstract** begin on page 3 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.

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